

ABSTRACT OF THE DISCLOSURE

A method and apparatus for circumferential application of materials to an interior surface of a curved pipe includes providing a pipe support with a rotational axis. A curved section of pipe is mounted to the pipe support. An arm supporting an applicator head is positioned within the curved section of pipe. The pipe support is rotated about the rotational axis, while coordinating movement of the arm to maintain the applicator head in a working position within the curved section of pipe.

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